

Application Data Sheet**Application Information**

Filing Date:: 4/1/2005 12:00:00AM
Application Type:: Regular
Subject Matter:: Utility
CD_ROM or CD-R?: None
Title:: NEAR-FIELD EXPOSURE METHOD AND
APPARATUS, NEAR-FIELD EXPOSURE MASK,
AND DEVICE MANUFACTURING METHOD
Attorney Docket Number:: 00684.103076
Request for Early Publication:: No
Request for Non-Publication?: No
Total Drawing Sheets:: 4
Small Entity?: No
Petition included:: No
Secrecy Order in Parent Appl.?: No

Applicant Information

Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Natsuhiko
Family Name:: MIZUTANI
City of Residence:: Tokyo
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 5514

Representative Information

Representative Customer Number::	05514
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National stage of	PCT/JP2004/011648	08/06/2004

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-290164	08/08/2003	Yes

Assignee Information

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